Superhard Coatings

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a continuing desire to develop improved coatings to obtain better yet performance for a wide range of applications.

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Raymond L. Boxman received his S.B. and S.M. degrees in Electrical Engineering in 1969, and his Ph.D. in 1973, from M.I.T. Boxman was a Senior Research Engineer at GE 1978 until 1978, at which time he was appointed to the Faculty of Engineering at Tel Aviv University, where he currently chairs the Department of Interdisciplinary Studies, directs the Electrical Discharge and Plasma Laboratory, and is the incumbent of the Kaunitz Chair of Plasma Engineering. He was awarded the Jeffes Foundation Award, the Walter Dyke Award, and is a Fellow of the IEEE. Boxman served as Secretary of the International Symposia on Discharges and Electrical Insulation in Vacuum, as a member of the Program Committee and Session Chairman for the Hard Coatings and PVD Symposium of the International Conference on Metallurgical Coatings and Thin Films, and as chairman of the International Conference on Superhard Coatings.

Stan Veprek is Professor Emeritus and former Director of the Institute for Chemistry of Inorganic Materials, Technical University Munich (TUM), and visiting principal scientist at the Singapore Institute of Manufacturing Technology at Singapore. His research interests include materials and surface science, plasma chemical and physical vapor deposition, thin films and protective coatings, nano-crystalline silicon or Si, photoluminescence from nc-Si and organosilicon compounds. He teaches surface and material science at the TUM and National University of Singapore. He published more than 900 scientific publications and several books, the last one *Structural Nanocrystalline Materials* (Cambridge Univ. Press, 2007) he co-authored with C. Koch, I. Orella and S. Seal. He is a pioneer in the field of superhard nanocomposites, and recently, he studies these materials theoretically by means of ab initio density functional theory.

Vladimir Zhitomirsky was born in Lvov, Ukraine, in 1962. He studied electronic materials engineering in the Moscow Steel and Alloys Institute, and received a Ph.D. degree in Materials Science from the G.V. Kurpatov Institute of Physics and Mechanics, Lvov. Since 1992 he has been associated with Faculty of Engineering and the Electrical Discharge and Plasma Laboratory at Tel-Aviv University, where he currently is a Principal Research Associate and lecturer a graduate course "Metallurgical Coatings: Deposition Techniques and Properties." His research interests include PVD coating processes, vacuum arc deposition, plasma diagnostics in vacuum arc deposition systems, the mechanical properties of materials and thin films, and surface science.

Avi Raveh is Leader of the Thin Films Group at the Nuclear Research Center – Negev, Israel, where he investigates the preparation and characterization of thin films and low-temperature surface treatment in non-equilibrium and dual-frequency plasmas by PECVD and PVD, with the aim of understanding the structure and properties of wear and corrosion resistant coatings. He received his PhD degree in Materials Science and Engineering in 1989 from Ben Gurion University. He was selected as a research fellow of the Natural Sciences and Engineering Council of Canada, and from 1998-1992 he worked at Ecole Polytechnique, Montreal. During this time, he deposited and characterized diamond-like carbon and diamond coatings. During 1990-2000, as a visiting researcher at University of Chapel Hill, North Carolina, he investigated the development of silicon oxide and silicon nitride for micro-electronic applications. He currently teaches Technology of Thin Films and Surface Engineering at Ben Gurion University.

SVC Foundation News

John B. Fenn, Jr., Foundation Board member, reported at the 2007 SVC TechCon Annual Business Meeting that the Foundation under the leadership of the new Board of Directors, has reached a critical mass by developing a mission that can resonate with the membership of the SVC and beyond, as demonstrated by one way the Foundation is beginning to be used by his constituency. To date, more than $220,000 has been donated, with more than $42,000 in scholarships awarded to date. Cash donations and matching funds from the SVC ($37,000 to date) are significant, but it is important to note that well over half of the donations are from individual members. Following are some recent examples:

Bernard Henry, loved and respected by many in SVC and AIMCAL, passed away this year. In cooperation with both the SVC and AIMCAL, the SVC Foundation has established a special scholarship fund in his name that will allow individual designated contributions to be pooled in the hope of creating an endowed, perpetual Bernard Henry scholarship (if the amount raised exceeds $50,000), or one or more Bernard Henry scholarships if the amount raised is less. We encourage the friends of Bernard Henry, whether based in the SVC, or AIMCAL, to make a donation in his memory toward the goal of creating a perpetual, endowed scholarship in his name. See page 54 in this Bulletin for a tribute from SVC to Bernard Henry.

Michael Hansen

Michael Hansen was a Past President of the SVC who passed away several years ago. He was important to Jim Sooser in several ways, not only for his good nature and positive attitude, but also for introducing him to many aspects of the vacuum coating business and particularly, in 1977, to the SVC and the benefit of membership. Michael became active in the SVC, being President 1990-1992 and thus also had an important impact on many others. A donation to the Foundation in Michael's name was the perfect way for Jim to remember him and to remind others of his contributions. We remember him fondly.

Don Mattox has donated his 2007 Nathaniel Sugerman Memorial Award check to the Foundation. Don was an early supporter of the Foundation, and this gift shows his continued support and commitment to its cause. We appreciate both the symbolism and the substance of this gift.

The 2007 5K Fun Run and Walk, organized by Wolfgang Decker, had a total of 25 sponsors, 68 runners and walkers (at 6 a.m. no less), and raised a total of $9,200. Only in its second year, this continues to be a great success story. See page 40 for more details.

SVC Foundation Scholarships

In 2007 the Fundation awarded three scholarships as follows.

SVC Foundation Scholarship: Nicolas Vickers, undergraduate student, California Polytechnic State University

The Jane and Frank Warchol Scholarship: Manuel J. Godoy, undergraduate student, California Institute of Technology

The Fenn Scholarship: Martynas Audronis, graduate student, University of Sheffield, UK

A total of 11 scholarships have been awarded since the founding of the SVC Foundation in 2002. Nicolas Vickers wrote to let us know that our scholarship would allow him to complete his research. Following the desires of Jane and Frank Warchol to do more with their donation as soon as possible, more scholarships will be awarded next year. Frank Warchol, founder of VacuCoat Technologies, Inc., is now an active philanthropist and his advice to us is very helpful.

The Scholarship Committee works very hard to solicit, screen, and award scholarships. Last year's committee was Paolo Ranger, chair, with members Hans Barankova, and John B. Fenn, Jr. Several people have expressed interest in joining the committee next year. If you are interested, please contact Paolo at pranger@svcguest.net.

SVC Foundation Booth at the 2007 TechCon

Through a generous donation from SVC, the SVC Foundation had a booth this year at the 50th Annual TechCon in Louisville, KY. The booth artwork presented all of our current donors as well as the scholarship recipients through 2007. The booth also provided a valuable meeting spot to talk with new potential donors. Additionally, we used the booth to register runners for the 5K Fun Run and Walk.

In addition to financial support, we also solicited (and received) individuals who will serve on various committees (for example the Scholarship Review Committee). Thanks to all of you who visited the booth and to all of our current donors and volunteers. We will have a booth again next year, so those who missed us this year, please stop by and see how you can contribute to the Foundation Mission.

As a volunteer organization, we always need help at the board level or the committee level to organize the 5K Run and the Scholarship Committee. In particular we need help from individuals who can help us build up a better Foundation Web Site. 2007 is becoming a great year for us, and we hope that either by your donations or by your contributed time, you can help 2008 be an even greater year. Contact any board member or Jim Sooser at jsooser@aol.com.

Thanks to all of you for your support. In particular, I want to thank Vivianne Mattox and the SVC Board for their valuable behind the scenes support (this page, booth space, administrative support, etc.) that help make it possible for us to function effectively.

SVC Foundation Board Members

Jim Sooser, Chair (814/915-0610; jsooser@aol.com)
John Fabis, Vice Chair and Treasurer (610/814-0840; fabis.chris@ezn.com)
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Wolfgang Decker, 5K Run Organizer (724-827-8887; wdecker@vantfilm.com)